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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	David J. Bain et al.)
Serial No.:	10/710,653) Group Art Unit: 2836
Filed:	July 27, 2004) Before Examiner: NYA
For:	PRESSURE ASSISTED WAFER HOLDING	Confirmation No.: 4652
<i>Γ</i> .Ο()	APPARATUS AND CONTROL METHOD)

STATUS REQUEST

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Please advise as to the status of the above-identified application, as an Office Action has not been received.

If there are any charges with respect to this Status Request or otherwise, please charge them to Deposit Account No. 06-1130 maintained by applicants' attorney.

By:

Respectfully submitted,

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Thereby certify that this correspondence is being transmitted by facsimile addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, facsimile number (571) 273-8300.

January 11, 2006

Jessien I. Hustan